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Form PTO-1449.

U.S. Department of Commerce

Atty. Docket No.
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
NP	4,790,982	12/13/88	Jin S. Yoo, et al.	423	239	4/7/86
NP	4,957,718	9/18/90	Jin S. Yoo, et al.	423	244	11/24/87
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VIID	4,963,520	10/16/90	Jin S. Yoo, et al.	502	64	8/1/88
010	4,976,847	12/11/90	Ian E. Maxwell, et al.	208	120	8/24/89
NB	5,376,608	12/27/94	Richard F. Wormsbecher, et al.	502	61	1/27/93
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FOREIGN PATENT DOCUMENTS **CLASS** SUBCLASS TRANSLATION COUNTRY DATE DOCUMENT YES NO NUMBER NO 1,117,511 Canada (Albers) 52 252-4 C10G 0 461 851 A2 11.06.91 Europe 11/05

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Wormsbecher et al. VANADIUM POISONING OF CRACKING CATALYSTS: MECHANISM OF POISONING AND DESIGN OF VANADIUM TOLERANT CATALYST SYSTEM, J. Catalysis 100, 130-137 (1986)

EXAMINER ///

12-14-98

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.